

Notice of References Cited	Application/Control No. 10/629,336	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Tuan H. Nguyen	Art Unit 2813	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,297,527	10-2001	Agarwal et al.	257/306
	B	US-6,727,169	04-2004	Raaijmakers et al.	438/622
	C	US-6,734,565	05-2004	Zambrano et al.	257/774
	D	US-2003/0104638	06-2003	Kim et al.	438/3
	E	US-6,238,964	05-2001	Cho, Bok-Won	438/240
	F	US-5,918,118	06-1999	Kim et al.	438/238
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.